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REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2813

Attorney Docket: 040008-0305451
Client Reference: OG03-012

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
SHIM et al.

Confirmation Number: 6221

Application No.: 10/747,946

Group Art Unit: 2813

Filed: December 31, 2003

Examiner: Nguyen, Thanh T.

Title: A SUBMICRON SEMICONDUCTOR DEVICE AND A FABRICATING METHOD
THEREOF

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated April 19, 2005, the period for reply being extend
by a Two-Month Extension of Time filed herewith, please amend the above-identified
application as follows:

09/20/2005 MAHMED1 00000098 033975 10747946
01 FC:1202 100.00 DA

09/20/2005 MAHMED1 00000098 033975 10747946
02 FC:1252 450.00 DA

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